## **OCT0013-US**

## RESPONSE UNDER 37 C.F.R. 1.116 EXPEDITED PROCEDURE EXAMINING GROUP NO.: 1792

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

RUDOLF PETER MUIS ET AL.

Serial No.: 10/514,424

Filed: May 26, 2005

For: METHOD AND APPARATUS FOR

APPLYING A LAYER OF A

SECOND MATERIAL TO A LAYER OF A NANOCRYSTALLINE FIRST

MATERIAL

Confirmation No.: 8641

Art Unit: 1792

Examiner: ROLLAND, Alex A.

## REQUEST FOR RECONSIDERATION AFTER FINAL REJECTION

Mail Stop: AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on December 4, 2009, please reconsider the above-identified application in view of the following remarks.

No extension of time or other fees are believed to be due, except as detailed in the attached documents. However, any extension of time necessary to prevent abandonment is hereby requested, and any fee necessary for consideration of this response is hereby authorized to be charged to Deposit Account Number 50-2613.

Amendments to the Specification: none.

Amendments to the Claims: none.

Remarks: begin on page 2 of this paper.